



#124C
DELLA
8-14-03

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q56532

Hideya TAKEO

Appln. No.: 09/489,846

Group Art Unit: 2621

Confirmation No.: 6337

Examiner: Ryan J. Miller

Filed: January 24, 2000

For: ABNORMAL PATTERN DETECTION PROCESSING METHOD AND SYSTEM

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED

AUG 11 2003

Technology Center 2600

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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